# NV microscopy of thermally controlled stresses caused by $Cr_2O_3$ thin films

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Many modern applications, including quantum computing and quantum sensing, use substratefilm interfaces. Particularly, thin films of chromium or titanium and their oxides are commonly used to bind various structures, such as resonators, masks, or microwave antennas, to a diamond surface. Due to different thermal expansions of involved materials, such films and structures could produce significant stresses, which need to be measured or predicted. In this paper, we demonstrate imaging of stresses in the top layer of diamond with deposited structures of  $Cr_2O_3$  at temperatures  $19^{\circ}$ C and  $37^{\circ}$ C by using stress-sensitive optically detected magnetic resonances (ODMR) in NV centers. We also calculated stresses in the diamond-film interface by using finite-element analysis and correlated them to measured ODMR frequency shifts. As predicted by the simulation, the measured high-contrast frequency-shift patterns are only due to thermal stresses, whose spin-stress coupling constant along the NV axis is  $21\pm1$  MHz/GPa that is in agreement with constants previously obtained from single NV centers in diamond cantilever. Our widefield imaging demonstrates the NV microscopy as a convenient platform that could optically detect and quantify spatial distributions of stresses in diamond-based photonic devices with a micrometer precision. Our results also show that thin film structures produce significant stresses in them, that should be accounted for in NV-based applications.

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### I. INTRODUCTION

The Nitrogen-Vacancy (NV) centres in diamond are point defects consisting of a vacancy in the diamond lattice adjacent to a substitutional nitrogen atom [1]. Long coherence times of their electron and nuclear spins and possibility of being initialized and read optically made them widely studied as potential qubits and quantum sensors. Intensive studies of NV centers in the last decade have led to a large variety of sensing applications [2– 6], which benefit from nanometer resolution and roomtemperature operation of the NV-based devices, as well as from low toxicity and mechanical or chemical durability of their diamond matrix. Mostly these applications exploit the high sensitivity of NV centers to magnetic fields via ground state Zeeman effect by using the Optically Detected Magnetic Resonance (ODMR) detection [7], while an auxiliary sensitivity to electric fields caused by the temperature, or strain in the diamond lattice is isolated by measurement designs or disregarded.

Over the last decade the research on NV sensors for detecting strains or associated stresses in diamonds has intensified, likely due to progress in nano and micro photonics [8–10], surface acoustic wave usage for phonon coupling in NV based micro and nano mechanical systems [11, 12], as well as quantum computing [1]. The interaction of NV electronic spins with deformations of a diamond crystal is a principal part of many quantum information processing schemes. For example, strain gradients could encode the position information of each NV center in a shift of its optical transition frequency making densely packed NV centers individually addressable [13, 14]. It has also been suggested to use the interaction between the electronic configuration of the NV ground state and local strains, to increase the applicability of electron spin qubits by allowing to drive spin transitions, both magnetically allowed and forbidden [15].

Strain is the deformation or displacement of material that results from an applied stress, which is the force applied to a material, divided by the material's crosssectional area. Both strains (dimensionless) and stresses of a crystal are tensors, related by Young's modulus or elastic modulus, usually expressed in gigapascals (GPa). Quantitative quantum sensing of strains or stresses in the diamond relies on knowledge of spin-strain or spin-stress coupling constants, which relate them to shift of NV spin energy sublevels expressed in frequencies of the ODMR.

Strains also appear inadvertently in various nanoscale devices, exacerbated by their structural or material diversity. For example, stains could be created by chromium films that are often used in nanofabrication due to their exceptional adhesion to the diamond surface, and have a linear thermal expansion coefficient, which is many times greater than that of the diamond. The physical and chemical properties of the materials, such as electronic, optical, magnetic, phononic, and catalytic properties can be dramatically alternated under application of stresses [16], especially at the nanoscale [17]. Fortu-

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nately for NV-based applications, the NV center itself could be used for quantitative characterization of local stresses [18, 19], providing an intrinsic and accurate sensing, whatever we want to mitigate or exploit the strains. Ensembles of NV centers, in turn, can be used for mapping of stresses in a shallow NV layer [20–24]. The latest study demonstrates high sensitivity ac magnetometry for three-dimensional strain mapping with micron-scale spatial resolution with two order-of-magnitude improvement in volume-normalized sensitivity [25]. Besides the material quality control, NV sensing is recently proposed for strain-based detection of dark matter [25, 26].

Even though the coupling between the NV spin and the diamond deformation has been previously studied in combined quantum-mechanical systems, several inconsistencies exist in available literature. Thus, this type of coupling constants has been investigated by use of an diamond anvil [18], and then consequently used in imaging of a partial stress tensor caused by intrinsic diamond defects [20] and imaging of full stress tensor caused by various mechanical impacts [21]. The last paper also reported surprisingly large stress contributions from functional electronic devices fabricated on the diamond. Following these studies, a complete formalism was proposed [19] to describe the coupling between the NV spins and crystal deformation, which in combination with an experimental method based on single NV centers in a deformed diamond cantilever [27] leads to a new set of four spin-stress constants that differs by a factor of  $\approx 2-3$  from reported in Ref. [18].

In this work we demonstrate a simple but accurate method of applying mechanical strains to a diamond crystal via  $Cr_2O_3$  thin film microstructures by controlling temperature of the film-diamond interface. The method benefits from different thermal expansion coefficients of the commonly used in NV sensing materials producing stresses, which are localized in a shallow layer close to the diamond surface and are homogeneous in planes parallel to the surface over relatively large regions under the film patches. On the one hand, we used the widefield diamond microscopy to map the stresses as the strainsensitive frequency shift of ODMR signals in a shallow NV layer. On the other hand, we calculated the stresses by finite-element methods based on our knowledge of the system geometry and involved material mechanical properties. The correlation of the both methods allowed us to quantify spin-stress coupling in the NV coordinate basis, and also compare it to the recently reported range of values [18, 19].

## **II. EXPERIMENTAL METHODS**

### A. Detection principle

Figure 1 depicts the NV energy levels with optical excitation and emission pathways. When the green laser light continuously excites NV centers, the ground-state population is optically polarized into  $|0\rangle$  state by a nonradiative, spin-selective decay via intermediate singlet states. Because of the same spin-selective decay mechanism, NV centers excited from  $|0\rangle$  state emit fluorescence in the red region of the spectrum at a higher rate than those originating from  $|\pm 1\rangle$  states. Application of a transverse microwave (MW) magnetic field mixes the spin populations, resulting in a decrease in fluorescence (a resonance) when the MW frequency matches the spin transition frequencies,  $f_{\pm}$ . Evaluation of these frequencies by precisely measuring of NV fluorescence as the MW frequency is swept across the resonances is the basic principle of ODMR techniques [7].



FIG. 1: NV energy level diagram depicting magnetic sublevels  $(|0\rangle, |\pm 1\rangle)$ , their phonon bands (green and red horizontal lines), optical excitation (green arrow), fluorescence (red arrows), and nonradiative (gray arrows) pathways. Gray arrows show spin-selective intersystem crossing leading to polarization into the  $|0\rangle$  ground-state sublevel.

When a magnetic field  $B_{\parallel} > 1 \text{ mT}$  is applied along the N-V symmetry axis z, the  $|0\rangle \leftrightarrow |\pm 1\rangle$  spin transition frequencies are [20]

$$f_{\pm} = D(T) + M_z \pm \gamma_{NV} B_{\parallel}, \qquad (1)$$

where  $D(T) \approx 2.87$  GHz is the temperaturedependent [28] zero-field splitting at room temperature,  $M_z$  is the effective electric field component associated with mechanical stress, and  $\gamma_{NV} = 28$  GHz/T is the NV gyromagnetic ratio. In general, there are four other components  $M_x, M_e, N_x, N_y$  associated with mechanical stresses, which are significant only at  $B_{\parallel} \approx 0$  [19, 29, 30] or in the vicinities (51.2 and 102.4 mT) of levels anticrossing [31–33].



FIG. 2: Graphical representation of the NV center in the diamond unit cell denoting the coordinate systems of the NV center (xyz) and the unit cell (XYZ) employed in this work. Yellow spheres depict carbon atoms, a blue sphere – substitutional nitrogen, and a black sphere – a lattice vacancy.

In the simplest but full description, the coupling constant  $M_z$  is expressed in terms of stress tensor components  $\sigma_{ii}$  and spin-stress coupling constants (stress susceptibility parameters)  $a_1$  and  $a_2$  [19] as

$$M_z = a_1(\sigma_{XX} + \sigma_{YY} + \sigma_{ZZ}) + 2a_2(\sigma_{YZ} + \sigma_{XZ} + \sigma_{XY}),$$
(2)

where XYZ are diamond unit cell reference coordinates and xyz are NV reference coordinates (see Fig. 2). One can see that the measurement described by Exps. 1 and 2 is only sensitive to the totals of axial and shear components of the stress tensor. A more sophisticated measurements are needed to obtain each individual  $\sigma_{ii}$  contributions [20]. In this paper, we show that Exp. 2 could be approximated by an empirical expression in the NV reference frame as

$$M_z \approx a_{NV} (\sigma_{xx} + \sigma_{yy} + \sigma_{zz}), \tag{3}$$

using a single spin-stress coupling constant  $a_{NV}$  and axial components of the stress tensor.

Typically, the detected frequency shift (see Exp. 1) is caused by simultaneous effects of the stresses in a hosting NV centers diamond crystals, the bias magnetic field, stray magnetic fields, and temperature shift. The magnetic field effects could be separated by measuring both frequencies  $f_+$  and  $f_-$  which are shifted by approximately equal amounts in opposite directions [34, 35]. The shift of  $f_+$  and  $f_-$  by equal amounts in the same direction (common shift) is then caused by changes in local temperature and stresses. The NV sensing by widefield microscopy allows an alternative method for separation of these effects based on their spatial distributions. The bias mag-



FIG. 3: Schematic of the experimental apparatus for wide-field diamond microscopy. DAQ: data acquisition card; PC: personal computer.

netic field and temperature (due to the exceptional thermal conductivity of diamond) produce homogeneous shift background, against which local stray fields [34] or longitudinal stresses could be imaged. However, when measuring at low bias magnetic fields  $B_{\parallel} \sim 10 \text{mT}$  the resonance shifts due to paramagnetism/antiferromagnetism of the thin films are order of magnitude smaller (see Fig. 6) than those produced by the strain due to to thermal expansion coefficient mismatch and thus can be neglected even when measuring only a single NV transition.

## B. Apparatus

The experimental setup for widefield imaging is depicted in Figure 3. The diamond we use for the sensing is an electronics grade type IIa diamond (Element 6) with a (100) surface polish and with 3 mm × 3 mm × 0.1 mm dimensions. We performed Stopping Range of Ions in Matter or SRIM simulations [36] to determine implantation parameters required for fabrication of 100-nm-thick NV layer close to the diamond surface. The SRIM simulation data for the diamond used can be seen in Ref. [37]. The crystal was irradiated with <sup>14</sup>N ions at three separate energies (10 keV, 35 keV and 60 keV) with cumulative dose of  $5.5 \times 10^{12}$  ions/cm<sup>2</sup> by CuttingEdge Ions, LLC and then annealed at 800 C° under high vacuum for four hours to promote migration of vacancies to substitutional nitrogen defects.

The diamond sensor is placed on a coverslip in an epifluorescent microscope, in which the NV excitation and fluorescence detection are performed through the same an infinity-corrected  $40 \times$  microscope objective with numerical aperture of 0.65 (Olympus Plan N). The NV centers are exposed to 100 mW radiation guided by a single mode optical fiber and lens system from a Coherent Verdi V-18 laser. A dynamic transmissive speckle reducer (Optotune LSR-3005) is inserted into the laser beam path to suppress interference artifacts originating from the thin air gap between the diamond and the coverslip, as well as within the diamond plate. The NV fluorescence (650–800 nm) is separated by a dichroic mirror (Thorlabs DMLP567R) and imaged through a long-pass filter (Thorlabs FEL0600) on a sCMOS sensor of Andor Neo 5.5 camera, or on the photodiode (Thorlabs PDA36A-EC) for adjustments of optical system. The field of view detected by the camera is a  $110 \times 110 \ \mu\text{m}^2$ . The air gap between the coverslip and the diamond reduces the diffraction-limited spatial resolution to ~ 1.3  $\mu$ m (NA of the microscope objective sets the fundamental limit of resolution to ~ 700 nm).

The bias magnetic field  $B_0 \approx 12.3$  mT is produced by a neodymium permanent disk magnet and aligned along one of the NV axes (surface polished along the (100) direction) at 35.5° to the diamond surface. The MW field is produced by a SRS SG384 generator, which frequency is slowly swept by analog voltage of a sawtooth waveform. The waveform is delivered from a data acquisition card (NI USB-6001). The amplified MW field (Mini Circuits ZHL-16W-43-S+ amplifier) is delivered by a copper antenna, which was e-beam deposited on the coverslip [34] in the form of a straight flat wire with  $100 \times 1.5 \ \mu m$  cross section.

The MW frequency is swept across central frequency of an ODMR ( $|0\rangle \leftrightarrow |-1\rangle$ ) profile with deviation of ±15 MHz. The MW sweep is triggered by a pulse from the cSMOS camera, which follows by a series of 40 frames per a sweep. One frame (512 × 512 pixel) acquisition time is 90 µs. Five series are averaged in the camera memory before reading out by a LabVIEW interface. In result, we obtain a series of NV fluorescence images revealing an ODMR shape for each pixel in a region of interest. In post-processing, we fit a series pixel-wise with a Lorentzian function to obtain a two-dimensional map of ODMR central frequencies.

We present two series of ODMR images. One is measured at ambient temperature (19°C) of the laboratory and another is measured during heating the diamond at 37°C. When heating, Minco HK5207 thermofoil fed by Thorlabs TED200C temperature controller covered roughly half of the diamond plate, which had a thermocouple attached for temperature feedback. The low power of the laser and the MW fields do not contribute by a detectable amount to the heating of the diamond.

## C. $Cr_2O_3$ thin films

 $Cr_2O_3$  thin film is deposited by reactive pulsed-DC magnetron sputtering at 26 °C (average temperature). The Cr target (99.95 % purity) of 2" in diameter and 3 mm thick is kept at 13-cm distance from diamond substrate under the flow of Ar (20 sccm) and O<sub>2</sub> (3 sccm). The deposition is performed with an average power of 150 W at chamber pressure of 1 Pa for 13 min. Fol-

lowing the film deposition, AZ 1518 photoresist is spincoated for 30 s at 4000 RPM (1 s acceleration) and subsequently creating an etch mask by exposure via laser writer Heidelberg µPG101. Samples were immersed in Chrome etchant (Sigma Aldrich 651826) for 35 s to remove  $Cr_2O_3$  from exposed areas followed by a rinse in deionized water. A grid of 10 µm × 10 µm squares with spacing of 10 µm between them is fabricated on the top of NV sensor as a result (Fig. 4). The thickness of the squares is  $256 \pm 1$  nm as is measured by 3D optical profiler Zygo "NewView 7100". Before the measurements the diamond with the thin film structures was cleaned in Piranha solution (3:1 sulfuric acid and 30% hydrogen peroxide solution), to remove any organic residue.

Initially, the  $Cr_2O_3$  structures were fabricated to study transitions from antiferromagnetic to paramagnetic properties at Néel temperature of 34 °C. It is found by Xray photoelectron spectroscopy (XPS) that the chemical composition of the thin films is only 67% Cr<sub>2</sub>O<sub>3</sub> and the remaining part is pure chromium - a material with a seven-fold lower magnetic susceptibility. Considering the purpose of this study, that composition is not a disadvantage because the both materials have the same excellent adhesion to diamond surface and similar thermal expansion coefficients. The mean of linear thermal expansion coefficients reported in literature [38-40] for  $Cr_2O_3$  is  $6.7 \pm 0.5 \times 10^{-6}$  K<sup>-1</sup> at room temperature. The corresponding coefficient of pure chromium is  $6.6 \times 10^{-6}$  $K^{-1}$  [41]. The linear thermal expansion coefficient of the diamond at room temperature is only  $0.8 \times 10^{-6} \text{ K}^{-1}$  [42] that is eight times less than for  $Cr_2O_3$ . This difference could lead to significant stresses in the diamondchromium interface when the operating temperature is different than the film deposition temperature.

We calculate stresses in the diamond-chromium interface by finite element analysis using solid mechanics package in COMSOL Multiphisics platform. We perform 3D simulation of nine chromium rectangular structures (each  $10 \times 10 \times 0.25 \ \mu m^3$ ), called here "squares" for simplicity, on the top of a diamond plate  $(50 \times 50 \times 4 \ \mu m^3)$ . The peripheral squares are necessary to correctly calculate stresses under the uncoated area around the central square. Coordinate axes of the geometry are directed along the diamond edges or such that one of the axes is along the NV axis which obtained by sequential rotation of  $45^{\circ}$  in the horizontal plane and  $35.5^{\circ}$  in the vertical plane relatively to the diamond side. Volume reference temperature is set to the deposition temperature (26  $^{\circ}$ C). Components of the stress tensors (Gauss point evaluation, spatial frame) are vertically averaged in a 200-nm-thick top layer of the diamond using the general projection function. The same model is used with AC/DC package (mf physics) to calculate stray magnetic fields induced by the bias magnetic field. In this case we set magnetic susceptibility of the squares to  $+1960 \times 10^{-6} \text{ cm}^3/\text{mol.}$ 



FIG. 4: (left) Reflected light image of a grid of the 256-nm thin  $Cr_2O_3$  squares deposited on a diamond substrate. A structure in the left top corner is a defect of the grid, used as a spatial reference. (middle and right) Maps of measured deviations  $\Delta f$ from a mean value of ODMR ( $|0\rangle \leftrightarrow |-1\rangle$ ) frequency for 19 °C and 37 °C, correspondingly. The interrogated NV axes in the [100]-cut diamond substrate are aligned along a diagonal of the square and tilted 35.5° to the XY plane.

## III. RESULTS AND ANALYSIS

#### A. Frequency shift imaging

Figure 4 (left) shows a reflected light image of  $\text{Cr}_2\text{O}_3$ thin films (dark) deposited on the diamond sensor's surface (bright). This image is taken by using the same optical system and camera, but the laser light is replaced with white light illumination. The small dark spots are likely the surface roughness of the diamond crystal. They do not appear in ODMR shift images shown in Fig. 4 (middle and right). However, the areas under the  $\text{Cr}_2\text{O}_3$ structures are clearly frequency-shifted. Although the  $\text{Cr}_2\text{O}_3$  films at 37 °C are paramagnetic, we do not expect any magnetic signals to be detected at the applied bias magnetic field  $B_0 \approx 12.3$  mT except the homogeneous shift  $\pm \gamma_{NV}B_{\parallel}$ . In a material with similar magnetic properties such stray field structures are detected at hundreds of millitesla [34, 43].

Another parameter that causes a frequency shift is temperature, the ODMR frequencies are homogeneously shifted by D(T) with 74 kHz/K [28]. The homogeneous background is subtracted by normalization to the mean frequency of each image, revealing local deviations  $\Delta f$ from the homogeneous shift. Patterns and signs of deviations  $\Delta f$  are qualitatively consistent with expected changes in stress distributions due to cooling to 19 °C and heating to 37 °C of the film-diamond interface, which is stress free at the deposition temperature of 26 °C; because of the different thermal expansion coefficients, the cool films shorten NV axes in the the upper layer of the diamond, but the warm films elongate them, resulting in corresponding changes of the effective electric field component  $M_z$ .

### B. Stress calculation

The  $M_z$  is usually expressed by all six components of the stress tensor in the crystal unit cell reference frame through two coefficients of the linear combination, see Exp. 2. Therefore, a 2D map of any component of the sensor or totals of axial or shear components would be quantitatively different from a correlated experimental image [20]. Here, we hypothesize that in the NV reference frame the shear components are negligible and the stresses could be conveniently expressed by a stress  $\sigma_{NV} = \sigma_{xx} + \sigma_{yy} + \sigma_{zz}$ , which is related by a single conversion factor to the measured frequency shift  $M_z$ , see Exp. 3. Figure 5 shows the simulated patterns of stresses  $\sigma_{NV}$  in the 100-nm thick top diamond layer, calculated with the procedure described in Subsection C of Experimental methods. In the simulations we account for the effect of optical diffraction by convolution with a two-dimensional Gaussian kernel ("blur") with 700-nm FWHM. The simulations show that at 19  $^{\circ}C$  Cr<sub>2</sub>O<sub>3</sub> films squeeze atoms in the top layer of the diamond, and at 37 °C they stretch the atoms. These crystal lattice changes are almost homogeneous under the whole area of films except edges and qualitatively similar to the corresponding  $\Delta f$  maps shown in Fig. 4. Near the edges of films signs of stresses are flipped because the films push or pull the uncoated areas. For some reasons, these edge effects are not prominent in the experimental maps. The difference between calculations and experiments might be a result of chemical etching related artifacts, that change the geometry of the thin film edge, diverging from a perpendicular side of the thin film square.

Figure 5 (right top) shows vertical distribution of stresses  $\sigma_{NV}$  in the XZ plane cut through the center of a Cr<sub>2</sub>O<sub>3</sub> square. Figure 5 (right bottom) shows vertically averaged  $\sigma_{NV}$  under the center of Cr<sub>2</sub>O<sub>3</sub> square versus the NV layer and the Cr<sub>2</sub>O<sub>3</sub> film thickness. The NV



FIG. 5: Simulation of stresses  $\sigma_{NV} = \sigma_{xx} + \sigma_{yy} + \sigma_{zz}$  averaged over a top 100-nm-thick layer of the diamond substrate at 19 °C (left) and 37 °C (middle). Stresses are caused by Cr<sub>2</sub>O<sub>3</sub> thin structures on a diamond substrate at stress-free temperature of 26 °C. Geometry and dimensions are the same as in Fig. 4. (right top) Simulated stresses in the XZ plane cut through the center of a Cr<sub>2</sub>O<sub>3</sub> square. The Cr<sub>2</sub>O<sub>3</sub> films appears as "overexposed" (white or black colors) because they experience much larger stresses than the diamond under them. (Bottom right) Stresses averaged over an NV layer under the center of a Cr<sub>2</sub>O<sub>3</sub> square versus the thickness of the NV layer and the film.

thickness has negligible impact on stresses  $\sigma_{NV}$  under the film. Such a low impact is an advantage, because the thickness of NV layer is estimated indirectly from simulation of ions implantations and diffusion of vacancies. The thickness of the films structures, in turn, could be directly measured with a nanometer precision, leading to a negligible contribution to stress uncertainty. The stress  $\sigma_{NV}$  almost linearly depends on the film thickness providing an additional mean to control stress in the NV layer. According to our simulation, there is an impact of the diamond plate dimensions on the stress magnitude, which however becomes negligible when thickness of the diamond substrate becomes larger than 20 µm and its latitude larger than 50 µm.

#### C. Stress-spin coupling analysis

For an analysis of contributions of different effects and correlation of the measured and simulated data we calculate profile plots from the 2D images. The measured maps are first prepared in the following way. To reduce noise of  $\Delta f$  images, we divide each image in segments with a thin film square in each and overlap them upon matching the squares. After taking a mean of the overlapped images, we obtain an averaged  $\Delta f$  map with a single square of Cr<sub>2</sub>O<sub>3</sub> film. Then the profiles are obtained by averaging  $\Delta f$  values over rows (x profile) in an 4 µm wide band across a square. The same profiles are calculated through the central square in calculated maps of stresses and maps of stray magnetic fields. In addition to the  $\sigma_{NV}$  image, we calculate two maps of totals of axial and shear tensor components in the XYZ reference coordinates and convert them into a map of  $M_z$  by using Exp. 2 and coefficients from Ref. [19].

Figure 6 shows the measured (solid lines) and calculated (dotted lines) profiles. The range between the solid gray vertical lines marks the diamond region coated with the Cr<sub>2</sub>O<sub>3</sub> film. The blue profiles are for measurements and simulations at temperature of 19 °C, but the red profiles are for the data at 37 °C. Brown dotted lines are used to depict the profiles of the calculated paramagnetic signals  $B_{\parallel}$  from the Cr<sub>2</sub>O<sub>3</sub> film at temperature of 37 °C. Confidence bands around the simulated stress curves are obtained from extreme estimations of mean thermal expansion coefficients for Cr<sub>2</sub>O<sub>3</sub> crystals [38–40].

Both vertical and horizontal profiles show good qualitative and quantitative agreement between the experimental data and calculations with spin-stress coupling constants reported in Ref. [19]. The experimental data have less pronounced peaks near edges of the films, likely because of the etching related artefacts mentioned before and also due to imperfections in stacking images of 14 squares, which resulted in some blurring of sharp features. Nevertheless the flips of the sign of stress are evident in the profiles. Moreover, both experimental and simulated profiles have weak asymmetry due to the specific geometry where NV axis is tilted relative to the surface.

A question may arise if magnetic fields or temperature could also contribute to the shapes of the profiles. Regarding the first, we do not expect any magnetic features that could exceed the frequency noise at 37  $^{\circ}C$  (see brown dotted lines in Fig. 6) where the thin film is paramagnetic and even more so at 19  $^{\circ}C$  where the thin film is antiferromagnetic. The temperature gradients are un-



FIG. 6: Horizontal (left) profiles of ODMR frequency maps obtained by averaging  $\Delta f$  values over rows in an  $\approx 4 \,\mu\text{m}$  wide band across a square formed by spatially overlaying and averaging 14 square features (see, Fig. 4). Solid lines show experimentally measured  $\Delta f$ , but dotted lines of the same color are  $M_z$  calculated by finite-elements simulations with help of Exp. 2 and constants reported in Ref. [19]. Confidence bands around the simulated curves are obtained by feeding into the model extreme estimations of mean thermal expansion coefficients for  $\text{Cr}_2\text{O}_3$  crystals [38–40]. Brown dotted lines represent the simulated paramagnetic signal created by the  $\text{Cr}_2\text{O}_3$  film at 37 °C. (right) Horizontal profiles of stress-induced  $\Delta f$  maps calculated in the crystal coordinate system XYZ (dotted lines) with use of the full stress tensor and spin-stress coupling constants  $a_1$  and  $a_2$  reported in [19], and in xyz coordinate system of the NV center (solid lines) with use of diagonal components of the stress tensor multiplied by a factor of 18. The range between the solid gray vertical lines marks the region where the  $\text{Cr}_2\text{O}_3$  thin film is deposited on the diamond surface.

likely because of the excellent thermal conductivity of diamond. However, we could suppose that the laser radiation heats films on the diamond surface leading to a slightly warmer NV layer volume under the  $Cr_2O_3$  films. While we do not know an amplitude of such an alleged effect, our simulations with an arbitrary difference of diamond and film temperatures reveal that the temperature shift would be maximal under the center of a film structure, gently decreasing toward the edges of the film. The temperature-caused frequency shifts at both experimental temperatures (red and blue profiles) would be negative and would most of all affect the central parts of the profiles. As there is no evidence of such distortion in Fig. 6 we conclude that within the margin of error only stress patterns contribute to the profile shapes and amplitudes.

### D. Spin-stress coupling coefficients

Two different sets of spin-stress coupling constants are recently reported [18, 19]. They differ by a factor ~ 2–3 and in their signs. One set is obtained through applying uniaxial stress to a diamond cube in a diamond-anvil cell [18] and another set is obtained through applying stress to a diamond cantilever [19]. The weakness of both methods is a need to calculate local stresses by using macro dimensions of a whole diamond chunk. In this study, we calculated the local stresses based on wellknown thermomechanical properties of the diamond and  $Cr_2O_3$  thin film interface. Besides the mechanical properties, the local stresses in such a system depend only on the thickness of film structures, which is known with a nanometer precision. On the other hand, the range of thermal linear expansions coefficients, which are reported in literature [38–40], leads to a narrow confidence band around calculated profiles of  $\Delta f$  in Fig. 6.

The relatively wider confidence bands in Figure 7 represents uncertainties of the spins-stress coupling coefficients reported in the literature [18, 19] for our calculated profiles of stress-induced  $\Delta f$ . These profiles are calculated using the same procedure as in Fig. 6 and shown alongside with the measured profiles. The constants  $a_1$ and  $a_2$  (Exp. 2) used for gray profiles (dotted lines) are from Ref [18]. This set of constants, which is often used in stress imaging [20, 44], does not predict the strong frequency shift signals that we observe. Profiles calculated with a set of constants  $a_1$  and  $a_2$  from Ref. [19], are presented as blue and red dotted lines for 19 °C and 37 °C, correspondingly, and our measurements clearly support spin-stress coupling coefficients from this set.

#### E. NV coordinate system

Finally, in Fig. 6 (right) we compare profiles calculated in XYZ reference frame with help of precise Exp. 2 with profiles calculated in xyz reference frame with help of approximated Exp. 3. The profiles are calculated using the same procedure as in Fig. 6 (left). One can see that both expressions lead to profiles, which are almost identical except little differences in vicinity of film edges. The xyz reference frame is convenient for the most NV-based measurements and one has to know only





FIG. 7: Horizontal profiles of measured maps of ODMR frequency  $\Delta f$  for 19 °C (top) and 37 °C (bottom) compared to simulated NV frequencies by using spin-stress coupling constants reported in Ref. [19] (colored dotted lines) and in Ref. [18] (gray dotted lines). Confidence bands are defined by uncertainties of the constants provided in the corresponding references. Note that compressive stress is defined to have negative amplitudes here, while Ref. [18] define positive amplitudes for it.

one spin-stress coupling coefficient  $a_{NV}$  to unambiguously link stresses experienced by NV axes with stressinduced frequency shifts. We estimate this coefficient  $a_{NV} = 21 \pm 1 \text{ MHz/GPa}$  from a linear fit of measured  $\Delta f$  confined in the central region  $(3 \times 3 \ \mu m^2)$ of the Cr<sub>2</sub>O<sub>3</sub> square versus corresponding totals ( $\sigma_{NV}$ ) of axial components of the stress tensors in xyz reference frame, as shown in Fig. 8 (top). From the same data set expressed in temperature units we obtain the temperature dependence of stress-induced frequency shift df/dT = 3.7 kHz/K, Fig. 8 (bottom). This value is specific to the studied film-diamond interface and its magnitude is  $\approx 20 \times$  less than the homogeneous temperature shift dD/dT = 74 kHz/K [28]. However, a frequency shift of 3.7 kHz is comparable to an ODMR shift of 132  $\mu$ T in magnetic field measurements. Note that from Fig. 8 (bottom) we can estimate the stress-free temperature, which is  $\approx 26$  °C – in a reasonable agreement with the predefined temperature of the film deposition.

FIG. 8: (top) Measured frequencies  $\Delta f$  (blue scattered dots) vs. simulated longitudinal stresses in the central region (3 × 3 µm<sup>2</sup>) of the Cr<sub>2</sub>O<sub>3</sub> square. The longitudinal spin-stress coupling constant in the inset is derived from linear fit (blue solid line). The gray area depicts standard deviations of the fit residuals. (bottom) The same measured frequencies  $\Delta f$  as above but shown vs. temperature scale.

#### IV. SUMMARY AND OUTLOOK

We have applied widefield stress imaging technique, which was previously demonstrated in Refs. [20, 44], to a diamond-film interface. In a proof-of-principle study we demonstrated the ability of our method to estimate spinstress coupling coefficients and confirmed coefficients previously found in Ref. [19]. Unlike other methods of spinstress measurements, our method is not limited by uncertainty of macroscopic dimensions of a diamond sample. The diamond-film interface is a versatile tool as it enables both: local stress sensing by ODMR technique and local stress inducing by means of ambient temperature.

There is a number of methods that can be used for measurements of stresses or associated strains in diamond: Rayleigh scattering [45], electron spectroscopy [46], X-ray tomography and microscopy [47–49], Raman spectroscopy [50], cathodoluminescence [51], and birefringence measurements [20, 49, 50]. However, these methods require the light or electrons to pass through the diamond, while the stress information is accumulated throughout the irradiated volume. The exception is atomic force microscopy and X-ray microscopy, which can only be used for surface measurements [52]. Unlike these methods, NV imaging can detect stresses in a hundred-nanometer thick layer fabricated next to the surface of the diamond. This technique has many degrees of freedom, many of which are still unexplored. There are four different directions of NV axes and any of them can be interrogated separately. Besides, the diamond surface can be cut to create NV ensembles with axes parallel or normal to surface. Finally, dispersed NV centers could be interrogated for stresses one by one, providing nanometer resolution in an imaging plane. Moreover, the optical detection of magnetic resonance allows to image stresses through the diamond, without accumulating the stress information outside the NV layer.

We used thin films of  $Cr_2O_3$  to induce and alter stresses in the NV layer. Under the film at distance of ~ 2 µm from its edges, magnitude of such stresses is homogeneous in a plane parallel to the diamond surface and its uncertainty is limited by thickness of the thin film, which is known with a nanometer precision. The stress appeared when ambient temperature is different from the film deposition temperature due to difference of thermal expansion coefficients. By setting the ambient temperature one can apply desired stress to the NV centers, for example to move it off and on a magnetic resonance.

Stress gradients created in normal to the diamond surface direction or near the edges of the film can encode the position information of each NV center in a shift of its optical transition frequency making densely packed NV centers individually addressable [13, 14], thus specifically designed systems could surpass optical resolution without using super-resolution microscopy techniques. Additional studies are needed to estimate maximum stresses and their gradients achievable by the diamond-film interface.

On the other hand, stresses could be mitigated by operating a device at a stress-free temperature. One example of such a device would be a microwave antenna that can be deposited on the surface of the diamond; this gives a well controlled distance between the NV layer and the emitter [53]. However, antenna (typically 5 nm thick chromium adhesion layer coated with hundreds nm thick gold or copper film) creates a stress gradients near its edges, that effectively changes the orientation and length of NV axes, as the strain bends the crystal. Moreover, when the microwave radiation is flowing through the copper wire, the electrical resistance could cause changing temperature, resulting in dynamically changing stress gradients. This could lead to a degraded sensitivity of an NV ensemble, as the ODMR profiles will get wider, and as consequence, NV centers near the antenna edges should not be used. Measuring of stresses under the antenna and under uncoated surface could reveal a stressfree temperature. Similar principles might apply to reflective coatings that are used for some applications, and other cases of material deposition on the surface of the diamond [54] as well as gluing diamond crystals to different surfaces [23, 55].

In this study we show that difference of just seven degrees from the stress-free deposition temperature may results in prominent ODMR frequency shift near the films. This results may appear counter-intuitive as it is easy to imagine that exceptional hardness of the diamond could resit to expansion of "soft" thin films. Knowledge of such stresses could help to account for, to avoid and even to exploit them.

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